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#5

FORM PTO-1449	SERIAL NO. 10/054,330	CASE NO. 10989-005
LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT (use several sheets if necessary)	FILING DATE January 22, 2002	GROUP ART UNIT 3737
APPLICANT(S): Rich et al.		

REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS/ SUBCLASS	FILING DATE
<i>A.S.</i>	A1	6,268,161	07/31/2001	Han et al.		
	A2	6,328,699	12/11/2001	Eigler et al.		
<i>A.C.</i>	A3	6,201,980	03/13/2001	Darrow et al.		
	A4					
	A5					
	A6					
	A7					
	A8					
	A9					
	A10					
	A11					
	A12					
	A13					

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	COUNTRY	CLASS/ SUBCLASS	TRANSLATION YES
	A14					
	A15					
	A16					
	A17					
	A18					

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EXAMINER INITIAL	OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)	
<i>A.S.</i>	A19	A Passive Wireless Integrated Humidity Sensor, Timothy Harpster et al. 2001, pp. 553-557
	A20	Electrodeposited Copper Inductors for Intraocular pressure Telemetry; R. Puers et al.; 2001 pp.124-129
<i>A.C.</i>	A21	Hermetically Sealed Inductor-Capacitor (LC) Resonator for Remote Pressure Monitoring; Eun-Chul Park et al.; 9/8/1998; pp. 7124-7128
	A22	
	A23	
	A24	

EXAMINER <i>Alc Mun</i>	DATE CONSIDERED <i>7/16/04</i>
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



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U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS/ SUBCLASS	FILING DATE
<i>LS</i>	A1	5,337,747	08/16/1994	Neftel		
	A2					
	A3					
	A4					
	A5					
	A6					
	A7					
	A8					
	A9					
	A10					
	A11					
	A12					
	A13					

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EXAMINER INITIAL		DOCUMENT NUMBER	DATE	COUNTRY	CLASS/ SUBCLASS	TRANSLATION YES	NO
<i>LS</i>	A14	WO00/19888	04/13/2000	PCT			
	A15	WO00/30534	06/02/2000	PCT			
<i>LS</i>	A16	EP0812016	12/10/1997	Europe			
	A17						
	A18						

EXAMINER INITIAL	OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)	
<i>LS</i>	A19	Micromachined Planar Inductors on Silicon Wafers for MEMS Applications; Chong H. Ahn et al
	A20	
	A21	
	A22	
	A23	
	A24	

EXAMINER <i>LS</i>	DATE CONSIDERED 7/16/04
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